03560.003316.

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	Examiner: Not Yet Assigned		
HIDETOSHI TSUZUKI ET AL.)	Group Art Unit: Not Yet Assign		
Application No.: 10/606,956)	Group 120 Canada a de la companya de		
Filed: June 27, 2003)			
For: PLATING APPARATUS AND METHOD	; ;	September 29, 2003		

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Copies of the listed documents are also enclosed.

The concise explanation of relevance for the non-English documents is found in the specification where they are cited, in an attached abstract and, if provided, in a corresponding U.S. patent.

CONCLUSION

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

FITZPATRICK, CELLA, HARPER & SCINTO

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U.S. DEPARTMENT OF COMMERCE PE		ATTY DOCKET NO. APP		APPLICA	PPLICATION NO. 10/606,956			
		APPLIC	APPLICANT HIDETOSHI TSUZUKI ET AL.					
		FILING DATE June 27, 2003			GROUP Unassigned			
		FEE	N. P.	U.S. PATE	NT DOCUMENTS			
*EXAMINER INITIAL				NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
		5,804,466	09/08/98		Arao et al.	438	95	
		6,068,755	05/30/00		Matsuda et al.	205	333	
		6,077,411	06/20/00		Nakamura	205	138	
		6,133,061	10/17/00		Sonoda	438	69	
		6,346,184 B1	02/12/02		Sano et al.	205	199	
		2002/0063065 A1	05/30/02		Sonoda et al.	205	333	
		6,576,112 B2	06/10/03		Sonoda et al.	205	155	09/17/01
			FC	OREIGN P	ATENT DOCUMENTS		Ţ <u>.</u>	
		DOCUMENT NUMBER	DATE		COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
	JP	10-60686	03/03/98		Japan			Abstract
	JP	10-140373	05/26/98		Japan			Abstract & USP 5804466
	JP	10-195693	07/28/98		Japan			Abstract & USP 5804466
	JP	10-259496	09/29/98		Japan			Abstract & USP 6077411
	JP	11-286799	10/19/99		Japan			Abstract & USP 6133061
	JP	2002-155396	05/31/02		Japan			Abstract
	JP	2002-167695	06/11/02		Japan			Abstract & USP 6576112
		OTH	IER DOCUMENT	(S) (Includ	ing Author, Title, Date, Pertinent Pages, E	Etc.)		
			"a-SiC/a-S	i/a-SiG	e Multi-Bandgap Stacked		ls With Ba	ndgap
		Inoue, et al.; "A li substrate"; <u>Exten</u>	ght confine ded Abstra	ment e	effect in an a-SiGe solar co pan Soc. Applied Physics	ell on a 29 , 29-MF-2,	p-MF-22 s p. 747 (19	stainless steel 90).
EXAMINER					DATE CONSIDERED			

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Sheet _1_ of _1_

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.